

Layer-Dependent Interfacial Transport and Optoelectrical Properties of MoS₂ on Ultraflat Metals

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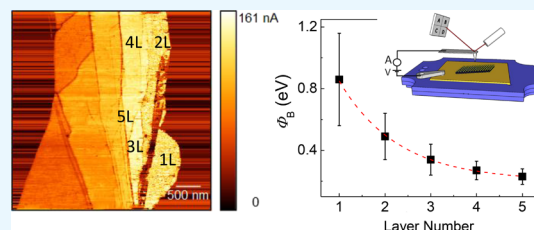
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Supporting Information

ABSTRACT: Layered materials based on transition-metal dichalcogenides (TMDs) are promising for a wide range of electronic and optoelectronic devices. Realizing such practical applications often requires metal–TMD connections or contacts. Hence, a complete understanding of electronic band alignments and potential barrier heights governing the transport through metal–TMD junctions is critical. However, it is presently unclear how the energy bands of a TMD align while in contact with a metal as a function of the number of layers. In pursuit of removing this knowledge gap, we have performed conductive atomic force microscopy (CAFM) of few-layered (1 to 5 layers) MoS₂ immobilized on ultraflat conducting Au surfaces [root-mean-square (rms) surface roughness < 0.2 nm] and indium–tin oxide (ITO) substrates (rms surface roughness < 0.7 nm) forming a vertical metal (CAFM tip)–semiconductor–metal device. We have observed that the current increases with the number of layers up to five layers. By applying Fowler–Nordheim tunneling theory, we have determined the barrier heights for different layers and observed how this barrier decreases as the number of layers increases. Using density functional theory calculations, we successfully demonstrated that the barrier height decreases as the layer number increases. By illuminating TMDs on a transparent ultraflat conducting ITO substrate, we observed a reduction in current when compared to the current measured in the dark, hence demonstrating negative photoconductivity. Our study provides a fundamental understanding of the local electronic and optoelectronic behaviors of the TMD–metal junction, which depends on the numbers of TMD layers and may pave an avenue toward developing nanoscale electronic devices with tailored layer-dependent transport properties.

KEYWORDS: MoS₂, layer dependence, electronic transport, photoconductivity, photoconductive AFM, metal–MoS₂ junction, Schottky barriers, density functional theory



INTRODUCTION

Layered transition-metal dichalcogenides (TMDs) are van der Waals (vdW) crystals, providing the tantalizing prospect of miniaturizing electronics to truly atomic scales and accelerating the advances of many two-dimensional (2D) optoelectronics.^{1–6} These atomically-thin layered TMDs demonstrate some unique properties that include 2D confinement, direct band gap nature,⁷ varying band structures with layer thickness,^{7–9} and weak screening of charge carriers enhancing the light-matter interactions.^{7,8,10} High photon absorption (e.g., for monolayer TMDs, absorption coefficient $\alpha \approx 10\%$ for visible light and $\alpha \approx 40\%$ for ultraviolet photons),^{7,11,12} and exciton formation^{7,11} make TMDs very attractive for different optoelectronic applications^{1,13–17} including sensitive photo-detectors,^{13,18–20} energy harvesting devices,^{21–23} monolayer

light-emitting diodes (LEDs),^{14,16,17} single photon sources,^{24–28} and nanocavity lasers.²⁹

Electronic and optoelectronic devices require a metal junction for injection and collection of current. Interfacial charge transport properties play a critical role in governing the current injection or collection in a metal–semiconductor junction. One property that controls charge transport across the junction is the barrier height because of the conduction band offset between the TMD and metal. Although significant progress has been made in demonstrating many different types of TMD-based devices, it is not clear how barrier heights

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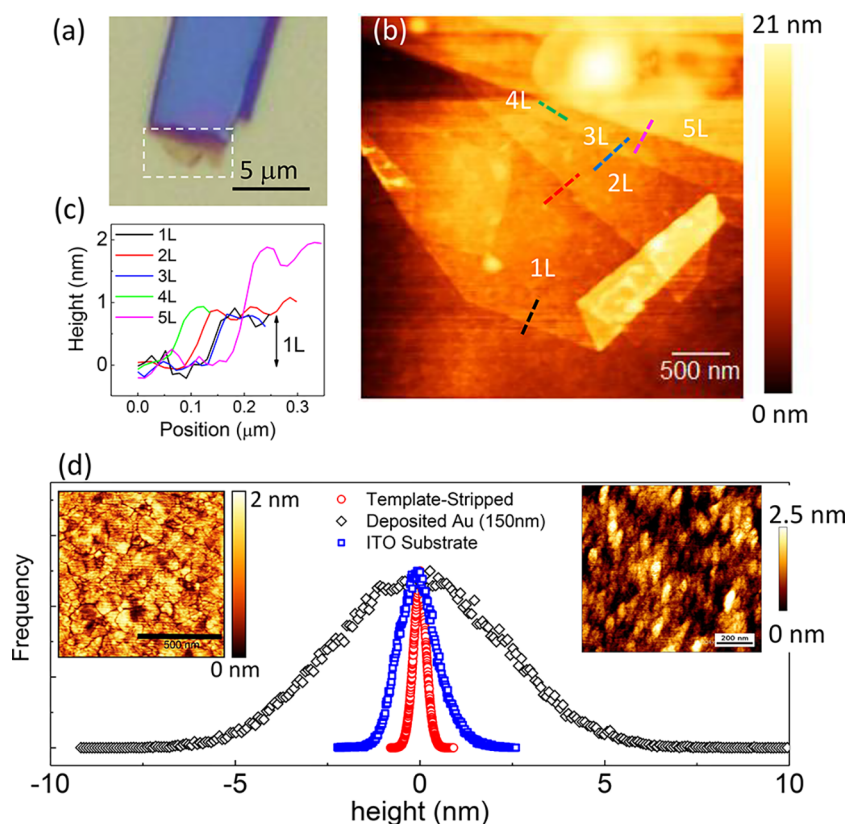


Figure 1. MoS₂ sample on a TS Au substrate. (a) Optical image of a MoS₂ sample. The dotted square region is studied using AFM and CAFM. (b) Height profile AFM image of the marked area (white dotted-square) in (a) measured by the AFM contact mode. The region of different layer numbers is shown. The scale bar is 500 nm. (c) Height profile AFM data extracted along the dashed lines marked in b. (d) Histogram of the height distribution (surface roughness measured by AFM) of the TS Au substrate (TS-Au, ~150 nm thickness), as the TE-Au substrate of thickness ~150 nm and the ITO substrate. Au for template stripping was deposited on a single crystal Si wafer. The root-mean-square (rms) value of the surface roughness measured was ~0.18 nm for TS Au and ~1.8 nm for the as-deposited substrate. Inset-left: The tapping-mode AFM image of the TS Au surface. Inset-right: the tapping-mode AFM image of 20 nm ITO-coated substrate on a single-crystal quartz substrate. The area of the scanned region is 1 $\mu\text{m} \times 1 \mu\text{m}$. The scale bar is 500 nm for the left image and 200 nm for the right image. A Gaussian fit to the height data provides full-width-half-maxima (fwhm) ~0.3 nm for the TS Au, ~5 nm for as-deposited Au, and ~1 nm for the ITO substrate. The surface roughness profile of template-stripped Au is very similar to surface roughness observed for h-BN (see text).

change with TMD thickness at the few-layer level (1L–5L).⁹ One standard technique to elucidate the barrier height is through the measurement of electron affinity by ultraviolet photoelectron spectroscopy (UPS). However, UPS requires a large sample ($\geq 100 \mu\text{m}$) which are challenging to prepare for few-layered (1L–5L) MoS₂ by exfoliation.^{30,31}

One possible alternative experimental route employs surface probe microscopy (SPM) to study local electrical transport and optoelectronic properties of few-layer TMDs. Because these 2D TMD materials conform to the surface roughness of the substrate, SPM requires that the sample resides on a surface with subnanometer roughness [root-mean-square (rms) surface roughness < 1 nm]. To understand the dependence of the barrier height on TMD layer thickness, we performed conductive atomic force microscopy (CAFM) and photocurrent atomic force microscopy (PCAFM) of few-layer MoS₂ samples immobilized on ultraflat transparent indium–tin oxide (ITO) and template-stripped (TS) Au conducting surfaces.

To probe the layer dependence of interfacial transport properties, CAFM and PCAFM measurements of few-layer MoS₂ samples with thickness varying from a monolayer (1L–MoS₂) to five layers (5L–MoS₂) were performed. To understand the effect of the tip material on the electrical and optical properties, Pt/Ir tips and platinum silicide (Pt/Si) tips

were used for both CAFM and PCAFM measurements. Similar results were observed for both Pt/Ir tips and Pt–silicide (Pt/Si) tips. Here, we present the results obtained using Pt/Si tips unless mentioned otherwise. We have studied three MoS₂ samples on the Au substrate and three MoS₂ samples on the ITO-coated substrate. All samples behaved similarly with respect to their electronic and optoelectronic properties. Several important features characteristic of the metal substrate/MoS₂/(Pt/Si) (tip) heterojunctions were observed; (i) the current increases as the layer number increases; (ii) the I – V curve analysis employed Fowler–Nordheim (FN) tunneling theory to give barrier heights that depended on the number of layers; (iii) the barrier height also depends on the type of the conducting substrate; (iv) the current was significantly lower along the edges of the MoS₂ basal plane; and (v) few-layer MoS₂ samples demonstrate negative photoconductivity when illuminated by blue light (460–490 nm). The barrier heights for 1L–5L MoS₂ on the Au(111) surface were calculated with density functional theory (DFT) and followed the observed experimental trends.

RESULTS AND DISCUSSION

Figure 1a,b show an optical image and the corresponding contact-mode AFM height profile image of exfoliated MoS₂ on

a freshly peeled TS Au surface. The TS Au substrate was prepared following standard procedures^{32–35} (see [Methods](#) for details). The height profiles of samples were measured mostly by contact-mode AFM. We have also used Raman spectroscopy as an indication of layer thickness, especially when the sample size is larger than the excitation beam diameter ($\sim 1\ \mu\text{m}$) (see details in the [Supporting Information S2](#)). The 1L–5L layer MoS_2 sheet structure is clearly observed in the contact-mode AFM height profile image, [Figure 1b,c](#). Before carrying out CAFM and PCAFM measurements, the rms roughness of the TS-Au and ITO substrates were measured and found to be 0.3 and 0.7 nm, respectively. The ultrasmooth nature of the TS Au surface is very close to the surface roughness of hexagonal boron nitrides (h-BNs),³⁶ a layered material commonly used as an atomically flat substrate. For comparison, the rms roughness of the external surface of the thermally evaporated (TE) gold layer was $\sim 2\ \text{nm}$. The metal surface roughness or morphology has an impact on the resistance level of a TMD device.³⁷ The left and right insets to [Figure 1d](#) show tapping-mode height profile images of the TS-Au and ITO-coated surfaces, respectively (see the [Supporting Information Figure S1](#) for an AFM image of a TE-coated Au surface). [Figure 1d](#) also compares the height histograms of the TS and TE gold surfaces confirming that template stripping produces a uniformly smooth surface with a narrow full-width-half-maximum (fwhm) distribution while the distribution and roughness of the TE surface are an order of magnitude larger. We have found that employing an ultraflat conducting surface as a substrate for exfoliated TMD is critical to observe consistent electrical and optoelectronic properties of atomically thin MoS_2 crystals.

Now, we discuss the electronic transport behavior of the MoS_2 sample on TS Au substrate. [Figure 2a](#) shows schemati-

cally the experimental setup used to measure the current under an applied voltage. The bottom inset shows the configuration of the sample with respect to the SiO_2/Si substrate. The MoS_2 sample was directly micro-exfoliated onto the TS Au surface. [Figure 2b](#) presents the direct current (dc) map measured with a 0.4 V bias of the sample whose height profile is shown in [Figure 1b](#). The spatial current map clearly demonstrates that the current increases as the layer number increases. This feature becomes clearer in the I – V curves obtained by averaging over a specific layer number as shown in [Figure 2c](#). To compare I – V without the sample, we also performed CAFM measurements of a bare TS Au-substrate and observed a linear I – V for low bias regime and nonlinear behavior for higher bias regime (see the data and analysis in the [Supporting Information S3](#)).

Interestingly, almost zero current was observed for the Au substrate outside the MoS_2 flake ([Figure 2b](#)). We attribute the nonconducting behavior observed for the gold substrate to the residue left after micro-exfoliation. To determine the reason, we conducted a control CAFM measurement of template stripped Au substrate before and after micro-exfoliation. We have observed that the conducting current drops by ~ 4 orders of magnitude (see the [Supporting Information](#)). This suggests that the micro-exfoliation process leaves residues and make the metal surfaces nonconducting.

When a metal tip is brought into contact with MoS_2 , a Schottky barrier forms, whose height depends on the work function of the Pt/Si tip and the electron affinity of MoS_2 .^{38–40} In the forward bias regime, high barrier heights suppress thermionic emission, and the barrier thickness is reduced with higher applied bias, which results in tunneling current. On the other hand, the current in the reverse bias is dominated by the thermionic emission above the barrier height. We have presented a detailed analysis of the I – V curve both in the forward bias and reverse bias in the [Supporting Information](#).

The forward biased current can be modeled by the FN tunneling model, which has been widely used to explain the tunneling of an electron between two metals separated by an insulator or semiconductor.^{40–43} The tunneling current through a thin semiconductor is given by

$$I(V) = \frac{A_e q^3 m V^2}{8\pi h \Phi_B d^2 m^*} \exp\left(-\frac{8\pi\sqrt{2m^*}\Phi_B^{3/2}d}{3hqV}\right) \quad (1)$$

where A_e is the effective contact area, h is Planck's constant, q is the electron charge, d is the thickness of the barrier, Φ_B is the barrier height, m is the electron mass, and m^* is the electron effective mass inside the semiconductor. We used $m^*/m \approx 0.35$ and 0.53 for monolayer MoS_2 and MoS_2 thicker than monolayer ($>1\text{L}$), respectively.⁴⁰ If the layer thickness d is known, we can apply [eq 1](#) to determine the barrier height from the I – V curves. More specifically, we replotted the I – V data as $\ln(1/V^2)$ versus $1/V$, whose slope is $\frac{8\pi\sqrt{2m^*}\Phi_B^{3/2}d}{3hq}$ and allows

measurement of the barrier height. Because the conducting substrate has surface roughness much smaller ($\sim 0.2\ \text{nm}$) than the thickness of monolayer MoS_2 ($\sim 0.65\ \text{nm}$), the separation between the bottom conducting surface and AFM tip remains constant for a specific layer number.

By using a multiple of 1L- MoS_2 ($\sim 0.65\ \text{nm}$) as the layer thickness, the barrier heights for different numbers of layers were calculated as shown in [Figure 2d](#). Interestingly, we observed that the barrier height decreases as the layer number

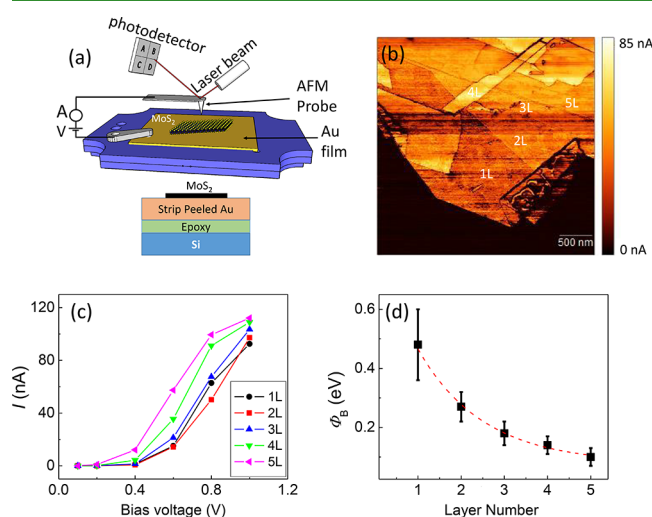


Figure 2. Layer-dependent conductive AFM measurement of the MoS_2 sample on a TS Au substrate. (a) (Top) Schematic diagram of the experimental setup (not to scale) used in CAFM measurements. The current is measured by a current amplifier. (a) (Bottom) Schematic diagram of the sample (see text for details). The MoS_2 sample was directly exfoliated on a TS Au substrate. (b) Conductive AFM data for the sample, whose height profile is shown in [Figure 1b](#). (c) I – V curves for different layers obtained by averaging the current for a flake. (d) Value of the barrier height measured by taking the average of every pixel. The red line is a guide to the eye. The error bar presents the standard deviation of the barrier heights.

increases. This suggests that the current increases as the number of layers increases, which is clearly evident both in the current map in Figure 2b and the I – V curves in Figure 2c. Our observations contrast with the findings of Son et al.,⁴⁰ who reported that the barrier height increases as the number of MoS₂ layers increases for a sample immobilized on a rough ITO surface.

To understand the impact of the substrate on the barrier heights, we also studied MoS₂ samples on ultraflat ITO-coated single-crystal quartz substrate. We found that commercially available ITO-coated substrates have high surface roughness and are not suitable for SPM measurement (see Figure S1 for details). The ITO thin films were deposited by physical vapor deposition onto transparent Z-cut quartz substrates (see the Methods section for details). An AFM surface profile image of the substrate is shown in the right inset to Figure 1d. The surface rms roughness of this transparent ITO-coated sample is ~ 0.7 nm.

The height profile of one MoS₂ sample on the ITO substrate is shown in Figure 3a. The current map for 1L–5L MoS₂ at 1.5

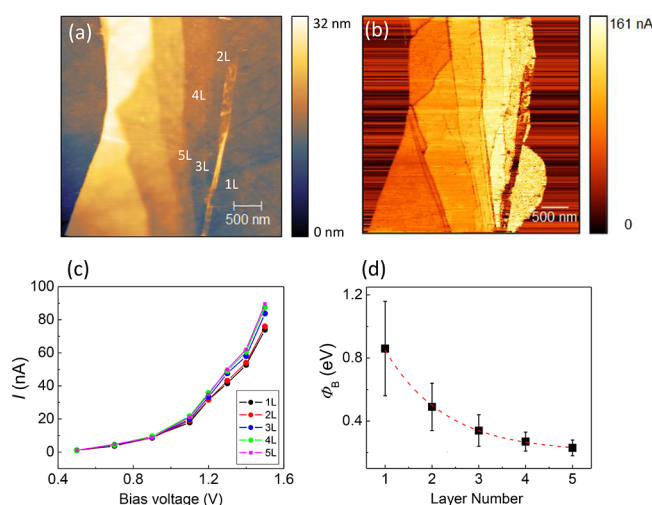


Figure 3. Layer-dependent conductive AFM measurement of the MoS₂ sample on a physical vapor-deposited ITO film. (a) Contact-mode AFM image of the height profile of a sample on the ITO-coated wafer. The layer numbers are shown. The scale bar is 500 nm. (b) Conductive AFM data for the sample for 1.5 V. (c) I – V curves for different layers obtained by averaging the current. (d) Calculated average value of the barrier height measured by taking the average of every pixel. The red line is a guide to the eye. The error bar presents the standard deviation of the barrier heights.

V bias voltage is shown in Figure 3b and clearly shows that the current increases with the increasing layer number. The corresponding I – V curves are shown in Figure 3c, which demonstrate that the current level increases, though minimally compared to MoS₂ on TS–Au, as the layer number increases from 1L to 5L. Note that the current level decreases above five layers. One possible explanation to account for this observation is that the barrier height does not change significantly with the MoS₂ layer number greater than five layers, whereas the sample thickness increases linearly. Hence, the tunneling current decreases significantly as the sample thickness (d) increases as predicted by the FN-tunneling model. Further study is necessary to understand the details of the electrical transport properties of MoS₂ samples thicker than five layers. The FN tunneling theory was used to calculate the barrier heights as

shown in Figure 3d. Although the layer number dependence of the barrier height for MoS₂ on ITO is very similar to the samples immobilized on a TS–Au substrate, the barrier height on the ITO substrate is much higher than the barrier heights of MoS₂ on the TS–Au substrate, which is likely caused by different work functions of ITO and Au in the presence of multilayer MoS₂.

We also studied exfoliated few-layer MoS₂ on TE rough Au substrate and commercially available rough ITO substrates. We could not extract any useful barrier height information because of high surface roughness (see details in the Supporting Information).

Another important feature observed in these MoS₂ samples (both on TS–Au and ITO substrate) is that the edges are less-conducting compared to the middle of the basal plane. The current drops by 2–5 times as the tip approaches the edge compared to regions far from the edges. The low current edges are especially visible, both in Figures 2b and 3b, as dark lines that trace the boundaries between adjacent layers. The current profile along three different edges is presented in Figure S2. Our estimate of the width of that insulating edge is ~ 20 nm, which is comparable to the Pt/Si tip width. This suggests that the insulating region is smaller than the Pt/Si tip and is beyond our measurement capabilities with our current AFM probe and setup.

To explain our experimental results, DFT calculations were performed to explore the interfacial electronic structure of 1L–5L MoS₂ on an Au(111) surface (Figure 4a). Figure 4b depicts the calculated electron affinity (χ_e) of isolated MoS₂ layers, which shows an increase of the electron affinity (lower conduction band minimum) with the increased layer number. The electron affinity reaches a plateau at about four layers. Figure 4c shows the calculated Schottky barrier, $\phi_B = W - \chi_e$, where W is the work function of Au/MoS₂. The calculated work function is shown in Figure S3 and shows a systematic decrease with layer thickness for the optimized structures. Figure 4c also shows the effect of increasing the interfacial distance between the MoS₂ layers and substrates. The imposed interfacial separation accounts for the possibility that the experimental interfacial spacing may not be exactly the same as the DFT-optimized ones (the black curve in Figure 4c) because of the corrugation of the Au surface and contaminants at the interface. The calculated Schottky barriers for an interlayer spacing of 1–3 Å between Au and MoS₂ shows the general trend of decreasing barrier with the increasing layer number, although ϕ_B reaches a plateau after three layers, which is more in line with the experimental results. Note that the calculated value of monolayer MoS₂ supported on Au in this study is very close to other computational studies.^{44,45} The different values of the barrier-height changes between calculations and experiments are likely caused by the challenge to accurately calculate the empty states using DFT, which is a ground-state theory. In addition, the presence of defects in the experimental samples may also lower the barrier height in MoS₂.⁴⁶ The increased electron affinity when adding additional layers of MoS₂ is manifested by the downshifted conduction band minimums, which are correlated with the reduced band gap in multilayer MoS₂ as compared to the monolayer.⁴⁷

Finally, we discuss the optoelectronic behavior of the exfoliated 1L–5L MoS₂ sample on an ultraflat ITO substrate. The MoS₂ (1L–5L) samples were immobilized on a transparent ITO substrate. The AFM stage was mounted on an inverted Zeiss microscope. MoS₂ was illuminated through

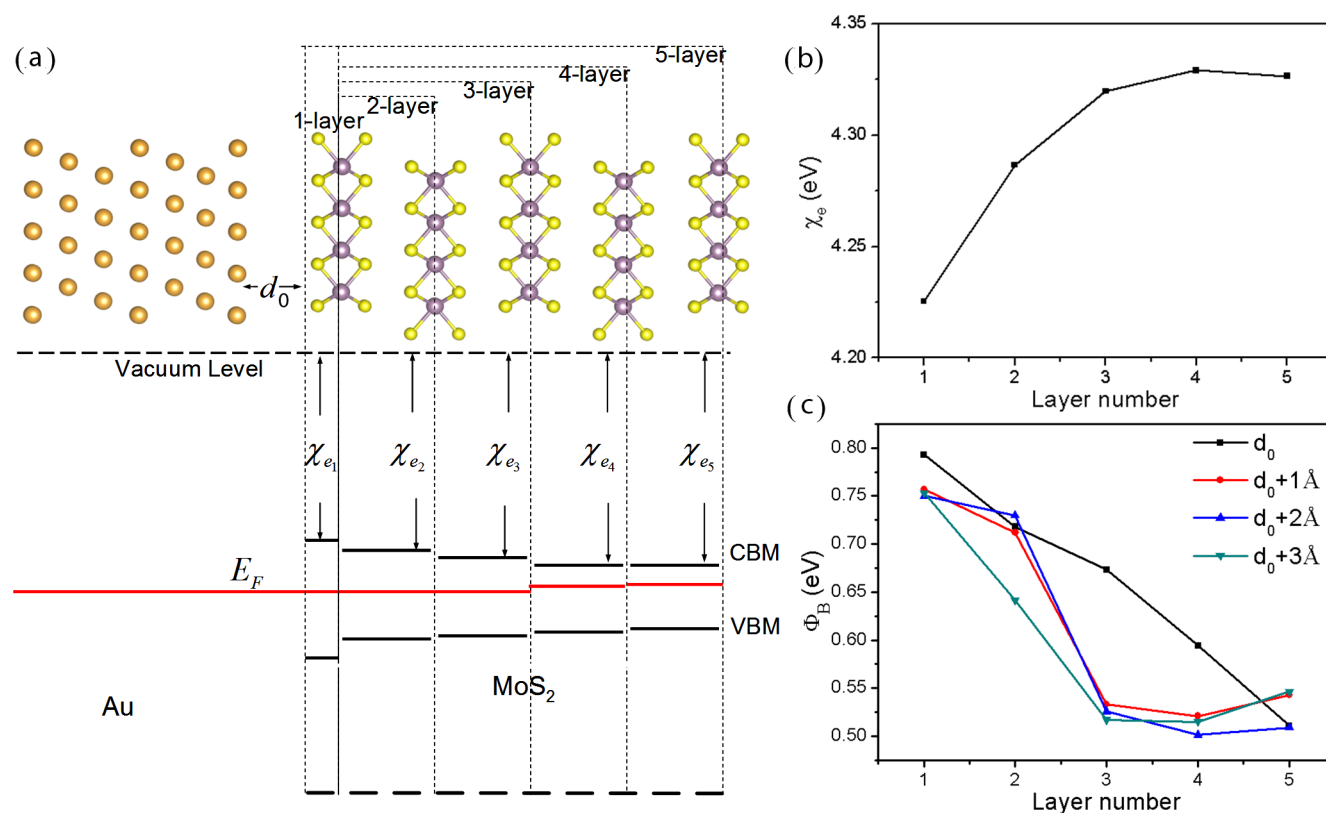


Figure 4. DFT-calculated interfacial electronic structure of Au/MoS₂. (a) Schematic of the MoS₂/Au interface and band alignment. The distance between MoS₂ and Au in the DFT-optimized structure is d_0 . (b) DFT-calculated electron affinity of MoS₂ with different thicknesses. (c) DFT-calculated Schottky barrier at the interface of Au/MoS₂ with varied thickness of MoS₂ and interfacial spacing. The black curve shows the values from DFT-optimized structures, while the red, blue, and green ones show the values when the structures are artificially displaced by 1, 2, and 3 Å further away from the Au surface, respectively.

the quartz substrate with an LED source (X-Cite 110), which employed a dichroic filter to select the excitation wavelength range of 460–490 nm. The excitation light was guided by a microscope objective ($\times 20$, NA ≈ 0.75) to the sample. The beam area was $\sim 10 \mu\text{m}^2$ with optical power density $P \approx 4 \text{ mW}/\mu\text{m}^2$. The height profile of the sample is shown in Figure 5a where different layer regions are marked. The corresponding I – V curve for 1L-MoS₂ is shown in Figure 5b. Surprisingly, the current decreases as the sample is illuminated by 460–490 nm photons demonstrating negative photoconductivity. Note that the change in photocurrent (ΔI_{PC}) becomes larger as we increase the bias voltage. The difference in current under illumination $\Delta I_{\text{PC}} (=I_{\text{light}} - I_{\text{dark}})$ for $V = 1 \text{ V}$ is shown as a spatial map in Figure 5c. The spatial map was made by subtracting the AFM current image acquired without illumination from the one illuminated with blue light, and it clearly shows that the current decreased under illumination. Another interesting feature is that ΔI_{PC} is larger for the thicker layer ($\geq 2\text{L}$) than the monolayer as shown in Figure 5d. The observation of negative photoconductivity of the single-crystal MoS₂ nanosheet is an anomalous photoresponse compared to regular positive photoconductivity behavior observed for planar structured TMDs.^{2,4,11,13}

We have also checked the negative photoconductivity of few-layer MoS₂ in a TS Au substrate. We illuminate the sample using a microscope objective underneath the sample in our inverted Zeiss microscope. This requires that the samples reside on a transparent substrate. Moreover, the Au metal layer needs to be thinner to reduce light absorption by Au itself. We

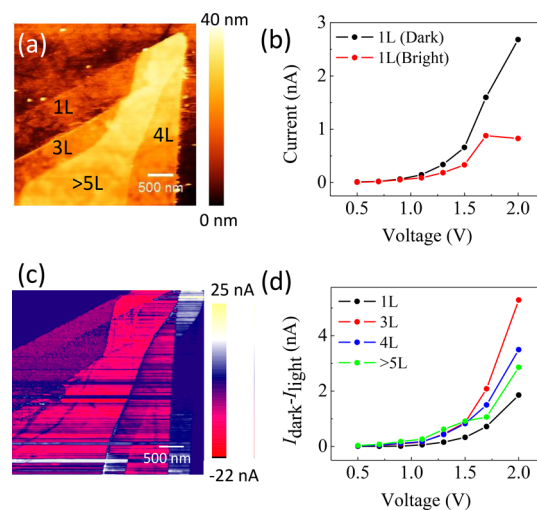


Figure 5. Photoconductive AFM measurement of the sample on an ultraflat ITO-coated single-crystal quartz. (a) Contact-mode AFM image of the height profile of the sample. Different layer regions are marked. The scale bar is 500 nm. (b) I – V curve when the sample is illuminated by blue light (black circle) and in the dark (red circle). (c) Photoconductive AFM image of the sample at $V = 1 \text{ V}$. The image is obtained by subtracting the illuminated photoconductive AFM image from the conductive AFM image measured in the dark. (d) Voltage-dependent negative photocurrent data ($=I_{\text{dark}} - I_{\text{light}}$) for different layers.

prepared a thinner TS Au substrate of 50 nm on a smooth glass substrate and micro-exfoliated few-layer MoS₂. We have observed significant negative photoconductive behavior similar to the few-layer MoS₂ samples on ITO (see the [Supporting Information](#)).

Negative photoconductivity of MoS₂ nanosheets connected by two metal electrodes in a planar or horizontal configuration was observed previously, and the effect was attributed to the strong many-body interactions in MoS₂.^{48,49} This many-body-related negative photoconductivity in the planar MoS₂ device configuration has transient nature with lifetime on the order of trions (~picoseconds). On the other hand, negative photoconductivity observed in our vertical metal/semiconductor/metal device structure is nontransient or time-independent, which suggests that the origin of negative photoconductivity in our devices is completely different than planar device configurations. One possible explanation is that the excited electron and holes after optical illumination in MoS₂ modify the barrier height, which therefore changes the tunneling current. Strong negative photoconductivity measured across the basal plane suggests that the barrier height increases because of optical illumination, which in turn reduces the tunneling current. Because photoconductivity is a critical parameter applied to optoelectronics, further study is necessary to elucidate the origin of this dc negative photoconductivity. Future work on determining the barrier height at different temperatures and optical powers may help pinpoint the reason behind the negative photoconductivity.

CONCLUSIONS

In conclusion, electrical and optoelectronic properties of 1L–5L MoS₂ samples residing on two different atomically flat conducting surfaces are probed by using CAFM and PCAFM measurements. We observed four important features of electrical and optoelectronic properties of MoS₂ nanosheets measured perpendicular to the basal plane. First, the FN tunneling theory shows that the barrier heights correlate with the number of layers; the barrier height is the highest for the monolayer and then monotonically decreases as the number of layers increases. By using DFT calculations, we attributed this observation to the increase of the electron affinity as the layer number increases. Second, the 1L–5L MoS₂ barrier height depends on the type of the conducting substrate underneath the sample; gold has a lower barrier height than ITO. Third, the edges of MoS₂ are less-conducting than the basal plane. Also fourth, negative dc photoconductivity was observed by illuminating the sample with blue light ($\lambda \approx 460$ – 490 nm). Our study revealed the interfacial electrical and optoelectronic properties while in contact with an ultraflat conductor and can lead to the development of nanoscale optoelectronic devices with tailored properties.

METHODS

Template-Stripped Gold Substrate. Prime-grade silicon (100) wafers were cleaned with a solution of water, ammonium hydroxide, and 30 wt % hydrogen peroxide in a ratio of 4:1:1 at a temperature of ~ 70 °C for 10 min (Standard Clean-1). The wafers were then rinsed with copious deionized water, dried under argon, and then placed in a bell jar. The bell jar was evacuated to a base pressure of 10^{-7} Torr, and then, 150 nm of gold was TE onto silicon at a rate of 5 Å/s. After the wafers were removed from the bell jar, pre-cut silicon pieces with dimensions 1 cm $\times$ 1 cm were adhered to the gold surface with Devcon 2-Ton Epoxy. To dry epoxy and make strong attachment, the diced wafer/epoxy/deposited-Au-film were kept under pressure for 24

h. The pressure was created by a block of heavy metal (5–7 pounds). Finally, the diced wafer was peeled/stripped using a razor blade. To avoid organic contamination of the freshly peeled gold surface, micro-exfoliated MoS₂ flakes from a bulk sample was transferred by direct contact with the gold surface within ~ 5 min after template-stripping.

ITO Thin Film Preparation. ITO films were deposited with physical vapor deposition onto transparent Z-cut quartz substrates. The films were sputtered from an as-purchased ITO target in a 10 mTorr Ar ambient at 65 W dc plasma deposition power at room temperature, with a deposition rate ≈ 3 nm/min. In this work, we have employed a 20 nm thick ITO-coated film. The samples were thermally annealed at 400 °C to reduce the sheet resistance (~ 220 Ω /square).

CAFM and Photoconductive AFM Measurements. CAFM and photocurrent AFM (PCAFM) measurement were conducted using a JPK Nanowizard 4a Bioscience integrated on an inverted Zeiss fluorescence microscope. The JPK conductive AFM module was used to conduct CAFM and PCAFM measurements. The total AFM system was mounted inside a JPK acoustic enclosure, which was also optically opaque. Hence the electrical measurement was conducted in a totally dark environment. For PCAFM measurement, the light was guided by a liquid light guide from an LED light source (X-Cite 110 LED) into a microscope objective ($\times 20$, NA ≈ 0.75). The blue illuminating light was filtered by a Zeiss dichroic filter (excitation BP 470/40). AFM images were analyzed and plotted using both Gwyddion software package⁵⁰ and JPK data processing software package. The Pt/Si (PtSi-CONT, resonant frequency, $f \approx 13$ kHz, force constants $k \approx 0.2$ N/m) and Pt/Ir (ANSCM-PC, $f \approx 12$ kHz, and $k \approx 0.2$ N/m) probe tips were purchased from NanoAndMore USA and Applied NanoStructures, Inc., respectively.

Raman Characterization. Confocal micro-Raman measurements were performed using commercial equipment (Horiba LabRAM Evolution). A 100 $\times$ objective lens with a numerical aperture of 0.9 was used. The excitation source was a 532 nm laser (2.33 eV) with an optical power of ~ 170 μ W.

DFT Calculations. The DFT calculations were performed within the framework of the plane-wave method as implemented in the VASP code.⁵¹ The exchange and correlation potential was described by using the generalized gradient approximation in the scheme of the Perdew–Burke–Ernzerhof functional⁵² and the projector-augmented wave method^{53,54} was employed to give the numerical description of the ion–electron interaction. A cutoff energy of 400 eV was used to limit the plane-wave basis set. The equilibrium distances between the optimized Au substrate and MoS₂ with different layer numbers were determined by calculating the minimums of the energy versus distance curves as relaxed under the stop criterion of 0.03 eV/Å per atom. A vacuum layer of 40 Å has been added to each composite structure of Au and MoS₂ to simulate the surface configuration. The vdW correction based on the Grimme's DFT-D2 method⁵⁵ and dipole correction along the direction vertical to the interface have been included to calculate the total energies and electrostatic potentials, which can provide reasonable atomic configurations at the interfaces and vacuum potentials.

ASSOCIATED CONTENT

Supporting Information

The Supporting Information is available free of charge on the ACS Publications website at DOI: [10.1021/acsami.9b09868](https://doi.org/10.1021/acsami.9b09868).

Surface roughness, Raman spectroscopy, transport between the AFM tip and bare Au before, I – V analysis, samples on rough thermally grown Au and commercially available ITO, transport along edges, work function calculations, PCAFM setup, and negative photoconductivity on different metal surfaces ([PDF](#))

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Notes

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